
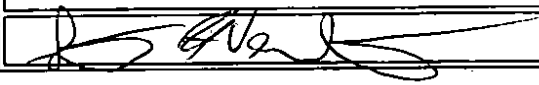




ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	PHYSICAL VAPOR DEPOSITION APPARATUS AND PROCESS						
Application Number:		10/063808					
Confirmation Number:		4319					
First Named Applicant:		Ramgopal Darolia					
Attorney Docket Number:		13DV-13711					
Art Unit:		1753					
Examiner:		Mr. Steven H. VerSteeg					
Search string:		(6007880).pn.					
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6007880	1999-12-28	Maloney		427	585
Signature							
Examiner Name				Date			
				June 1, 2004			

INFORMATION DISCLOSURE CITATION IN AN APPLICATION		Attorney Docket No. 13DV-13711	Application No. 10/063,808
Submitted by: <i>Domenica N.S. Hartman</i>		Applicant: Ramgopal Darolia, et al	
Domenica N.S. Hartman, Reg. No. 32,701		Filing Date: 05/15/03	Group Art No. 1753

U.S. PATENT DOCUMENTS

Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date if appropriate
	4,403,002	09/06/83	Akashi, et al	427	255.5	
	5,296,274	03/22/94	Movehan, et al	427	566	

RECEIVED
SEP 10 2003
TC 1700

FOREIGN PATENT DOCUMENTS

Examiner's Initials	Document Number	Date	Country	Class	Subclass	Translation Yes No
SHV	JP05156438	06/22/93	Japan	C42C	14/54	
SHV	JP06322521	11/22/94	Japan	C43C	14/56	
	EP1008669	06/14/00	Europe			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner <i>[Signature]</i>	Date Considered <i>June 1, 2004</i>

*Examiner: Initial if reference considered whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.